

Amendments to the Claims:

1 (Canceled).

2 (Currently Amended). The manufacturing method for a liquid crystal display device according to Claim 4 5, wherein the predetermined region is pressed in the bonding step.

3 (Currently Amended). The manufacturing method for a liquid crystal display device according to Claim ~~4~~ or 2 5, wherein the bonding step is carried out in an atmosphere of 2.7 k to 50 kPa.

4 (Canceled).

5 (Currently Amended). A manufacturing method for a liquid crystal display device, comprising the steps of:

applying a liquid crystal to a first substrate;

fixing the first substrate by a first vacuum chuck;

fixing a second substrate by a second vacuum chuck;

~~The manufacturing method for a liquid crystal display device according to Claim 4,~~
wherein

the second vacuum chuck ~~comprises~~ comprising a plurality of retaining regions on a chuck surface thereof, the plurality of retaining regions being capable of performing mutually independent retaining operations and being disposed outward from the center of the chuck surface, and

bonding a second substrate to a surface of the first substrate to which the liquid crystal has been applied,

the retaining operations of the plurality of retaining regions are being stopped in order outward from the center in the bonding step,

wherein a predetermined region of the second substrate is bonded to the first substrate, and the bonded region is expanded with the elapse of time.

6 (Currently Amended). The manufacturing method for a liquid crystal display device according to Claim 4 5, wherein the second vacuum chuck further comprises a holder that presses the second substrate, and the predetermined region is pressed by the holder in the bonding step.

7 through 10 (Canceled).

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3